

CORRECTION | DECEMBER 02 2013

Publisher's Note: "High yield fabrication of multilayer polydimethylsiloxane devices with freestanding micropillar arrays" [Biomicrofluidics 7, 056503 (2013)] **FREE**

Christopher W. Gregory; Katelyn L. Sellgren; Kristin H. Gilchrist; Sonia Grego



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This article was originally published online on 28 October 2013 with "polydimethylsiloxane" misspelled in the title, first line of the abstract, and second line of the Introduction.

AIP Publishing apologizes for these errors. All online versions of the article were corrected on 31 October 2013. The title appears correctly above.

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